

Notice of References CitedApplication No.
09/361,980Applicant(s)
Ito et al.Examiner
Lynette T. Umez-EroniniGroup Art Unit
1765

Page 1 of 1

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	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A					
B					
C					
D					
E					
F					
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O	03,012,960 A	1/1991	Japan	Iida	257	537
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U	Nagahata, Preparation of Thermal Head, English Abstract of JP 63062746 A, 2 pages.	3/1988
V	Iida, Semiconductor Device and Manufacture Thereof, English Abstract of JP 3012960 A, 2 pages.	1/1991
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